

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:	)	
	)	
Kazuya FUKUHARA	)	Group Art Unit: 2624
	)	
Application No.: 10/776,591	)	Examiner: Mia M. THOMAS
	)	
Filed: February 12, 2004	)	
	)	Confirmation No.: 3478
For: INSPECTION METHOD,	)	
PROCESSOR AND METHOD FOR	)	
MANUFACTURING A	)	
SEMICONDUCTOR DEVICE	)	

**MAIL STOP RCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT**

This amendment is being filed along with a Request for Continued Examination (RCE) and satisfies the requirement for a submission as set forth in 37 C.F.R. § 1.114. In response to the Office Action mailed August 19, 2008, the period for response to which extends through November 19, 2008, please amend the above-identified application follows:

**Amendments to the Claims** are reflected in the listing of claims in this paper beginning on page 2.

**Remarks** follow the amendment sections of this paper beginning on page 8.